

00862.022435.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Kiyoshi ARAKAWA)	Prior Examiner: H. Nguyen
)	Prior Group Art Unit: 2851
Application No.: Continuation of Application)	
No. 09/986,918, filed November 13, 2001)	
Filed: July 18, 2003)	
For: EXPOSURE APPARATUS, MAINTENANCE)	
METHOD THEREFOR, SEMICONDUCTOR)	July 18, 2003
DEVICE MANUFACTURING METHOD)	
USING THE APPARATUS, AND)	
SEMICONDUCTOR MANUFACTURING)	
FACTORY)	

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies listed documents are also enclosed.

These documents were cited during prosecution of copending parent application no. 09/986,918, filed November 13, 2001.

The Okabe article is discussed on pages 2 and 3 of the subject specification.

Japanese patent document numbers 6-260385 and 8-279458 are discussed on page 3 of the subject specification.

Japanese patent document number 2000-179950 is discussed on pages 3 and 4 of the subject specification.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed to be due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicant requests that the cited information be considered by the Examiner and that a copy of the enclosed PTO-1449 Form be initialed and returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW/cab

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Filed: July 18, 2003				ATTY DOCKET NO. 00862.022435.1		APPLICATION NO. Continuation of Appln. No. 09/986,918	
				APPLICANT Kiyoshi ARAKAWA			
				FILING DATE July 18, 2003		GROUP 2851	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US-4,676,614	06/30/1987	Ohno	353	101	
		US-5,243,377	09/07/1993	Umatate et al.	355	53	
		US-5,305,364	04/19/1994	Mochiji et al.	378	34	
		US-5,559,584	09/24/1996	Miyaji et al.	355	73	
		US-6,253,464	07/03/2001	Klebanoff et al.	34	403	

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		8-279458	10/22/1996	Japan			Abstract
		2000-195779	07/14/2000	Japan			Abstract
		2001-210587	08/03/2001	Japan			Abstract
		2000-179590	06/27/2000	Japan			Abstract
		11-219902	08/10/1999	Japan			Abstract
		6-260385	09/16/1994	Japan			Abstract
		1 030 351 A1	08/23/2000	Europe			
		1 098 225 A2	05/09/2001	Europe			

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Okabe, Hideo. "Photochemistry of Small Molecules," A Wiley-Interscience Publication, 1978, p. 178.

EXAMINER	DATE CONSIDERED
----------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1